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Bio Data Sheet

CONFIRMATION NO. 8493

SERIAL NUMBER 10/646,460	FILING DATE 08/22/2003 RULE <i>✓</i>	CLASS 156	GROUP ART UNIT 1763	ATTORNEY DOCKET NO. 006915/P9
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** CONTINUING DATA *****

This application is a CIP of 10/164,327 06/05/2002 PAT 6,939,434 *ms*

** FOREIGN APPLICATIONS *****

NONE ms

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 11/14/2003

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY CA	SHEETS DRAWING 85	TOTAL CLAIMS 24	INDEPENDENT CLAIMS 2
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged Examiner's Signature <i>Malik</i> Initials <i>ms</i>				

ADDRESS

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TITLE

Plasma immersion ion implantation system including an inductively coupled plasma source having low dissociation and low minimum plasma voltage

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